

**MODEL PREDICTIVE CONTROL OF VAPORIZER IN VINYL ACETATE  
MONOMER PROCESS**

**MOHD SHARIZAN BIN MD SARIP**

**A thesis submitted in fulfillment of  
the requirement of the award of the degree of  
Bachelor of Chemical Engineering**

**Faculty of Chemical and Natural Resources Engineering  
University Malaysia Pahang**

**MAY 2008**

I declared that this thesis entitled “*Model Predictive Control of Vaporizer in Vinyl Acetate Monomer Process*” is the result of my own researched excepted as cited in the references. The thesis has not been accepted for any degree and is not concurrently submitted in candidature of any other degree.

Signature : \_\_\_\_\_

Name : MOHD SHARIZAN BIN MD SARIP

Date : 29 APRIL 2008

To my beloved mother and father

## **ACKNOWLEDGEMENT**

I would like to take this opportunity to extend my deepest gratitude to the following persons who have helped me a lot in this project, which enable me to complete the research project in time a partial fulfillment of the requirement of the degree of Bachelor Engineering (Chemical Engineering).

Firstly and foremost, a special thank to my supervisor Mr. Noor Asma Fazli bin Abdul Samad, who helped me a lot during the progress of the research project, for all support, continuous patience and supervision given throughout the project. Without her time in sparing their precious time to guide me and answer my doubts, this project would not accomplish successfully.

I would like to give my heartiest appreciation to En Jawahir in guiding me and advising me during the completion of this project. His support and advice is indeed very much appreciated. Apart from that, I would like to thank our lecturer Miss Sureena bt Abdullah and Miss Rohaida bt Che Man for his guidance and coordination in this final year project.

Last but not least, my special thanks, I would like to direct to my family members for their continuous support and advice from the early stage of my studies.

## **ABSTRACT**

A Model Predictive Control (MPC) algorithm is developing on the Vinyl Acetate Monomer process provided by Luyben and Tyreus. Stress on the vaporizer, consideration only for the 'Single Input Single Output' (SISO) strategy with two control objective. Three closed loop have been applying with involve the vaporizer pressure and level. The MPC algorithm is implemented to the control loop by using Simulink/MATLAB 7.0. The limitation on the set-point using conversional controller would be overcome by using an advanced control method that is MPC. In direct comparison, we show that MPC algorithm would give better performance due to future prediction potential compare to conventional controller that is PI. The capabilities of MPC have been tested with three different inputs which represent the real mechanistic behaviors of chemical plant through the Simulink/MATLAB 7.0 simulations. The MPC algorithm is believed can capture the nonlinear and robust of Vinyl Acetate Monomer process that refers to real chemical industries.

## ABSTRAK

Kawalan peramalan model (MPC) dibangun dan diuji pada proses *Vinyl Acetate (VAc) Monomer* yang dibangun oleh *Luyben dan Tyreus(1997)*. Dalam kajian ini, kami hanya menumpukan perhatian kepada *vaporizer*. Kajian hanya tertumpu pada cara 'Satu Input Satu Output (SISO) dengan dua objektif kawalan. Dua pembolehubah kawalan, dua pembolehubah manipulasi dan dua pembolehubah penganggu dikenalpasti bagi menghapuskan perubahan pada *output*. Secara keseluruhannya MPC dibangun pada gelung kawalan dalam persekitaran *Simulink/MATLAB 7.0*. Kekangan pada input boleh diatasi atau dihapuskan dengan menggunakan MPC strategi. Dengan melakukan perbandingan, MPC dikenalpasti memberikan tindakbalas yang lebih positif berbanding dengan pengawal konvensional iaitu pengawal berkadar terus dan kamiran (PI).Kemampuan MPC diuji menggunakan tiga input yang berbeza bagi mewakili ketidakstabilan industri kimia yang sebenar menggunakan *Simulink/Matlab 7.0* simulator. Selain itu, MPC juga diakui boleh mengatasi masalah dinamik, tidak linear dan tidak sekata proses *Vinyl Acetate Monomer* yang merujuk kepada industri kimia yang sebenar.

## TABLE OF CONTENTS

CHAPTER PAGE	TITLE	
	ACKNOWLEDGEMENT	II
	ABSTRACT	III
	ABSTRAK	IV
	LIST OF FIGURES	VI
	LIST OF TABLES	V
	LIST OF SYMBOL	
	XIII	
	LIST OF APPENDICES	
	XV	
 <b>I</b>	 <b>INTRODUCTION</b>	
	1.1 Overview of Research	1
	1.2 Research Objective	4
	1.3 Scope of Study	4
 <b>II</b>	 <b>LITERATURE REVIEW</b>	
	2.1 Overview of Vinyl Acetate Monomer process	5
	2.1.1 Vinyl Acetate monomer Process modeling	7
	2.1.1.1 The Vaporizer	7
	2.1.1.2 The Catalytic Plug Flow Reactor	8
	2.1.1.3 The Feed Effluent Heat Exchanger	10
	2.1.1.4 The Separator	10

		11
	2.1.1.5 The Compressor	11
	2.1.1.6 The Absorber	11
	2.1.1.7 The CO <sub>2</sub> Removal System	13
	2.1.1.8 The removal System	13
	2.1.1.9 The Azeotropic Distillation Tower	13
	2.1.1.10 The HAc Tank	14
	2.1.2 Vaporizer	14
2.2	Model Predictive Control	15
	2.2.1 A Brief History of Industrial MPC	21
	2.2.1.1 Linear Quadratic Gaussian (LQG)	22
	2.2.1.2 IDCOM	23
	2.2.1.3 Dynamic Matrix Control (DMC)	25
	2.2.1.4 QDMC	30
	2.2.1.5 IDCOM-M, HIECON, SMCA, and SMOC	30
	2.2.2 MPC Calculations	31
2.3	Open Loop vs Closed Loop	31
2.4	DMC Tuning Process	32

### **III PROCESS MODELING AND DYNAMIC RESPONSE**

3.1	Introduction	34
3.2	Process Modeling	35
	3.2.1 Process Modeling in Vaporizer.	38
3.3	Dynamic Response	40
3.4	Conclusion	45

### **IV TRANSFER FUNCTION AND MPC IMPLEMENTATION**

4.1	Introduction	46
4.2	Transfer Function Development.	46
4.3	The Implementation of MPC	50
4.4	Tuning Process	52
	4.4.1 Tuning for Interacting Control Loop.	53



		12
	4.4.2 Tuning on the Vaporizer Level Control Loop	57
	4.4.3 Tuning for Vaporizer Pressure Control Loop	62
	4.4 Conclusion	66
<b>V</b>	<b>THE CAPABILITY OF MPC</b>	
	5.1 Introduction	67
	5.2 The MPC Performance on the Interacting Process	68
	5.3 The MPC Performance on Vaporizer Pressure.	70
	5.4 The MPC Performance on Vaporizer Level.	72
	5.5 Conclusion	74
<b>VI</b>	<b>CONCLUSION AND RECOMMENDATION</b>	
	6.1 Conclusion	75
	6.2 Recommendation.	76
	<b>REFERENCES</b>	77
<b>APPENDIX A</b>	<b>M.FILE FOR MPC PROGRAMING</b>	79

## LIST OF FIGURES

FIGURE NO. PAGE	TITLE	
2.1	Flowsheet of the Vinyl Acetate monomer process	6
2.2	Model predictive control block diagram	17
2.3	Model predictive control scheme	18
2.4	Model predictive control algorithm	20
2.5	Approximate genealogy of linear MPC algorithms	21
2.6	Hierarchy of control system functions in a typical processing plant.	22
2.7	Closed loop control system	32
2.8	Open loop control system	32
2.9	Non-adaptive DMC tuning strategy by Dougherty and Cooper.	33
3.1	Data generation for VAc process in condition A(a)	35
3.2	Data generation for VAc process in condition A(b)	36
3.3	Data generation for VAc process in condition B	36
3.4	Data generation for VAc process in condition C	37
3.5	Data generation for VAc process in condition D	37
3.6	The actual data for the vaporizer level in VAc process	41
3.7	The actual data for the vaporizer pressure in VAc process	42
3.8	Dynamic response for Vaporizer level in A condition	43
3.9	Dynamic response for Vaporizer level,% in D condition	44
3.10	Dynamic response for vaporizer pressure in A condition	43
3.11	Dynamic response for vaporizer pressure in B condition	44
3.12	Dynamic response for vaporizer pressure in C condition	44
3.13	Dynamic response for vaporizer pressure in D condition	45

4.1	The input changes (Vaporizer inlet pressure,psia)	47
4.2	Output changes (Vaporizer level, %)	48
4.3	Output changes (Vaporizer pressure, psia)	49
4.4	Simulink Open loop model for the process	50
4.5	Simulink closed loop model for the process	51
4.6	The tuning graph for the interacting process psia using Constants input	54
4.7	The tuning graph for the interacting process, psia using Random Number input	55
4.8	The tuning graph for the interacting process using Band Limited White Noise input	56
4.9	The optimum condition for interacting control loop	57
4.10	The tuning graph for the vaporizer level using Constant Input	58
4.11	The tuning graph for the vaporizer level using Random	
4.12	Number input	59
4.13	The tuning graph for the vaporizer level Band Limited White Noise input	60
4.14	The optimum condition for vaporizer level control loop	61
4.15	Tuning process on the vaporizer pressure using Constant Input	63
4.16	Tuning process on the vaporizer pressure using Random Number input	64
4.17	Tuning process on the vaporizer pressure using Band Limited White Noise input	65
4.18	The optimum condition for vaporizer pressure control loop	66
5.1	The comparison between the PI and MPC using Constant input (A)	66
5.2	The comparison between the PI and MPC using Random number input(A)	68
5.3	The comparison between the PI and MPC using Band Limited White Noise input(A)	69
5.4	The comparison between the PI and MPC using Constant Value (B)	70

5.5	The comparison between the PI and MPC using Random Number input (B)	71
5.6	The comparison between the PI and MPC using Band Limited White Noise input(B)	71
5.7	The comparison between the PI and MPC using Band Limited White Noise input(C)	72
5.8	The comparison between the PI and MPC using Random n Number input(C)	73
5.9	The comparison between the PI and MPC using Band Limited White Noise input(C)	73

## LIST OF TABLE

TABLE NO. PAGE	TITLE	
2.1	Vaporizer equipment data	14
3.1	Key loop of SISO strategy for Vaporizer	38
3.2	The dynamic response strategy	40
4.1	Tuning strategy for the interacting model.	53
4.2	Tuning strategy for the vaporizer level model.	61
4.3	Tuning strategy for the Vaporizer pressure model	62

## LIST OF SYMBOL

$a_i$	-	$i$ th unit step response coefficient
$A$	-	Dynamic matrix.
$CV$	-	Control variable
$d$	-	Disturbance prediction.
$DMC$	-	Dynamic matrix control.
$DV$	-	Disturbances variable
$e$	-	Predicted error.
$\tilde{e}$	-	Vector of predicted errors
$i$	-	Index
$I$	-	Identity matrix
$IDCOM$	-	Identification and command
$j$	-	Time index
$LQG$	-	Linear quadratic Gaussian (LQG)
$M$	-	Control horizon (number of controller output moves)
$MPC$	-	Model predictive control.
$MV$	-	Manipulated variable
$N$	-	Current samples
$N$	-	Model horizon.
$P$	-	Prediction horizon
$PI$	-	Proportional integral
$QDMC$	-	Quadratic dynamic matrix control
$Q, R$	-	Weighting matrices.
$SISO$	-	Single input single output
$VAc$	-	Vinyl Acetate monomer process
$u$	-	Controller output variable
$y_o$	-	Initial steady state of process variable
$\tilde{y}$	-	Predicted process variable.

$y_{sp}$	-	Process variable set point.
$\lambda$	-	Move suppression coefficient (controller output weight).
$\Delta t$	-	Sampling period.
$\alpha_i$	-	Reference rejection.

**LIST OF APPENDICES**

<b>APPENDIX</b>	<b>TITLE</b>	<b>PAGE</b>
A	M.FILE FOR MPC PROGRAMING	79



## CHAPTER 1

### INTRODUCTION

#### 1.1 Overview of Research.

In recent year, chemical industries face a lot of problem due to the economical considerations in the process industry. Generally, all chemical industries are inherently nonlinear. This, together with higher product quality specification, the increasing productivity demands and tightens environmental regulations. A further complication is that modern plants have become more difficult to operate because of the trend toward complex and highly integrated process. For such plant, it's difficult to prevent disturbances from propagating from one unit to other interconnected units (Seborg *et al*, 2003).

This make computer based process become very important to operate modern plants safely and profitably. Besides that, a new generation of process control is very important to reduce variability in the end product, which ensures a consistently high-quality product. By reducing variability, its also can save money by reducing the product padding to meet required product specifications. Padding refers to the process of making a product of higher-quality than it needs to meet some specifications. Furthermore, its can increase efficiency because some processes need to be maintained at a specific point to maximize efficiency. Otherwise, process control can ensure safety because sometimes a run-away process, such as an out-of-control nuclear or chemical reaction, may result if we do not maintain precise control of all the process variables. The proportional-integral (PI) controller has been widely used in the industry because of its simple structure and robust performance in a wide range of operating conditions. PI

The proportional-integral (PI) controller has been widely used in the industry because of its simple structure and robust performance in a wide range of operating conditions. PI control has reigned as the industrial standard, and for good reason: such as simple, fast, versatile, flexible, and a sensible design that the underlying algorithm hasn't changed one bit in all these years. But, the widespread use of PI, the technologies inherent its weaknesses which are:

- A. PI controls have difficulty handling process delays, nonlinear processes, and noisy process signals. This leads to suboptimal control and increased tuning effort.
- B. PI is not as robust as alternatives, often delivering higher process variability.
- C. PI tuning is not easy to handle. Effective tuning requires experience, extensive training, and an investment in tuning software.
- D. PI transfers process signal noise directly to its controller output. This accelerates valve wear and increases energy usage.

Considering to the pad simulation, the major problem using the conventional controller is the limitation on variability of set point tracking. For example, the PI controller for vaporizer pressure only let the range of 125 -130 psi. This limitation would make the controller cannot perform well when the changes of set point that is pressure. These weaknesses add up over time, with the net impact being PI use may actually increase process variability, decrease production and product quality, and ultimately increase operating and maintenance costs. Besides that, other factor that encourages the replacement of PI is:

- A. The evolution of control systems from pneumatics to distributed control system (DCS) to process knowledge systems.
- B. The convergence of hardware and software technologies
- C. Wider industry acceptance of advanced control technologies

Due to its high potential for global optimization, advanced controls such as Model Predictive Control (MPC) it's preferred as an alternative controller. Objective of MPC control calculation is to determine a sequence of moves by manipulates input changes so that predicted response moves to the set point in optimal manner.

MPC displays improved performance because the process model allows current computations to consider future dynamic events. For example, this provides benefit when controlling processes with large dead times or nonminimum phase behavior (Dougherty and Cooper, 2001). In MPC, the outputs would be a control variables and input is manipulated variables. Furthermore, the main element in MPC is predictor and optimizer. This combination would make MPC as a perfect controller rather than PI controller.

In this study, the MPC will be implementing on Vinyl Acetate Monomer process by Luyben and Tyreus (1998) in MATLAB 7.0 environment. The process has 10 unit operations, which includes a vaporizer, a catalytic plug flow reactor, a feed-effluent heat exchanger (FEHE), a separator, a gas compressor, an absorber, a carbon dioxide (CO<sub>2</sub>) removal system, a gas removal system, a tank for the liquid recycle stream, and an azeotropic distillation column with a decanter. But, this research only concentrates to control one unit operation that is a vaporizer.

## **1.2 Research Objective.**

The objective of this research is to implement the model predictive control at the vaporizer in Vinyl Acetate Monomer process.

## **1.3 Scope of Study.**

- A. To develop test-bed platform for nominal condition.
- B. Dynamic response on test-bed.
- C. Set-point tracking and disturbance rejection on Vinyl Acetate monomer process.
- D. Implementation of MPC on vaporizer pressure and level control loop for Vinyl Acetate monomer process.
- E. The tuning process for MPC controller.
- F. Performance comparison between the MPC and PI controller.

## CHAPTER 2

### LITERATURE REVIEW.

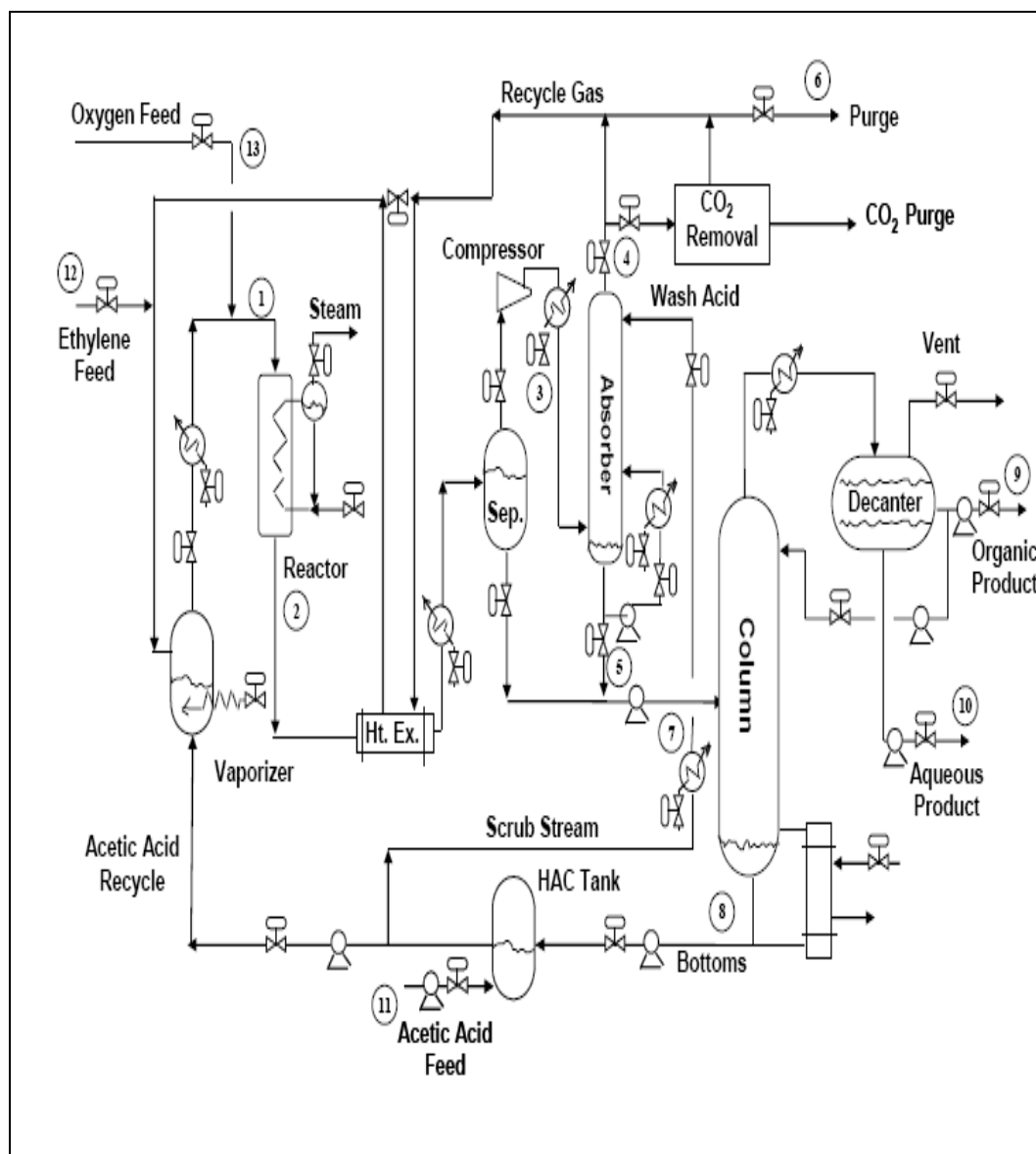
#### 2.1 Overview of Vinyl Acetate Monomer Process.

In 1997, Luyben and Tyreus was published a new plantwide control test problem based on the Vinyl Acetate monomer (VAC) process. Generally, this process would be the real plant wide problem for plant wide design, optimization, and control study with:

- I. A realistically large process flow sheet containing standard chemical unit operation.
- II. A process with the typical industrial characteristic of recycles stream and energy integration.
- III. A real Nonideal chemical components.

In the VAC process, there are 10 basic unit operations, which include a vaporizer, a catalytic plug flow reactor, a feed-effluent heat exchanger (FEHE), a separator, a gas compressor, an absorber, a carbon dioxide (CO<sub>2</sub>) removal system, a gas removal system, a tank for the liquid recycle stream, and an azeotropic distillation column with a decanter as shown in figure 2.1. There are seven chemical components in the VAC process that is Ethylene (C<sub>2</sub>H<sub>4</sub>), pure oxygen (O<sub>2</sub>), and acetic acid (HAc) are converted into the vinyl acetate (VAc) product, and water (H<sub>2</sub>O) and carbon dioxide

The following reactions take place:



**Figure 2.1: Flow sheet of the Vinyl Acetate Monomer Process (Luyben and Tyreus, 1997).**

### 2.1.1 Vinyl Acetate monomer Process Modeling

This section discusses design assumptions, equipment data, and modeling formulations for each unit operation. For each unit, the state and manipulated variables are identified.

#### 2.1.1.1 The Vaporizer

The vaporizer is implemented as a well-mixed system with seven components. It has a gas input stream ( $F_1$ ), which is a mixture of the  $C_2H_4$  feed stream and the absorber vapor effluent stream. It also has a liquid input stream ( $F_2$ ), which comes from the HAc tank. There are 8 state variables in the vaporizer, including the liquid level, the mole fractions of  $O_2$ ,  $CO_2$ ,  $C_2H_4$ , VAc,  $H_2O$ , and HAc components in the liquid, and the liquid temperature. The liquid level is defined by the ratio of the liquid holdup volume over the total working volume. Since the dynamics of the vapor phase are ignored, total mass, component and an energy balance are used to calculate the dynamics in the liquid as:

$$r_L^{VAP} \dot{V}_L = F_1^{VAP} MW_1^{VAP} + F_2^{VAP} MW_2^{VAP} - F_V^{VAP} MW_V^{VAP} \quad (2.3)$$

$$M_L^{VAP} \dot{x}_{L,i}^{VAP} = F_1^{VAP} (X_{1,i}^{VAP} - x_{L,i}^{VAP}) + F_2^{VAP} (x_{2,i}^{VAP} - x_{L,i}^{VAP}) - F_V^{VAP} (y_{V,i}^{VAP} - x_{L,i}^{VAP}) \quad (2.4)$$

$$C_{PL}^{VAP} M_L^{VAP} \dot{T}_L = F_1^{VAP} (h_1^{VAP} - h_L^{VAP}) + F_2^{VAP} (h_2^{VAP} - h_L^{VAP}) - F_V^{VAP} (h_V^{VAP} - h_L^{VAP}) + Q^{VAP} \quad (2.5)$$

Vapor liquid equilibrium (VLE) is assumed in the vaporizer, and as a result, the vaporizer pressure and the vapor compositions are determined by a bubble point

calculation. Two manipulated variables ( $Q^{VAP}$  and  $F_v^{VAP}$ ) are available in the vaporizer. In the base operation, the liquid holdup,  $V_L^{VAP}$ , is  $2.8 \text{ m}^3$ , which is 70% of the working level volume. The vaporizer is followed by a heater, and the heater duty is a manipulated variable. In the base operation, the heater exit temperature is specified to be  $150^\circ\text{C}$ .

### 2.1.1.2 The Catalytic Plug Flow Reactor

The reactor is implemented as a distributed system with ten sections in the axial direction. Two irreversible exothermic reactions, given by Eq. (2.1) and (2.2), take place. In the MATLAB model, the following assumptions are made for the purpose of model simplification:

- § Plug flow is assumed so that there are no radial gradients in velocity, concentration, or temperature. Diffusion occurring in the axial direction is considered negligible compared to the bulk flow. Potential and kinetic energy and work are considered negligible in the energy balance calculation.
- § It is assumed that the mass and heat transfer between the fluid and catalyst are very fast and therefore the concentrations and temperatures in the two phases are always equal.
- § Pressure drop is assumed linear along the length of a tube, and it is time-independent. Eqn.2.6 is used to calculate the pressure drop in each section:

$$\Delta P / \Delta Z = f * r_1^{RCT} * (u_1^{RCT})^2 \quad (2.6)$$